Supporting Information

High-performance PDMS-based triboelectric nanogenerator fabricated using surfacemodified carbon nanotubes via pulsed laser ablation

Kangpyo Lee,^{‡ab} Sungwook Mhin,^{‡c} HyukSu Han,^d Ohyung Kwon,^a Woo-Byoung Kim,^e Taeseup Song,^b Sukhyun Kang^{*a} and Kang Min Kim^{*a}

^a Korea Institute of Industrial Technology, 137-41 Gwahakdanji-ro, Gangneung-si, Gangwon,

25440, Republic of Korea. E-mail: tjrgus@kitech.re.kr; kmkim@kitech.re.kr

^b Department of Energy Engineering, Hanyang University, Seoul 04763, Republic of Korea

^c Department of Advanced Materials Engineering, Kyonggi University, Suwon 16227,

Republic of Korea

^d Department of Energy Engineering, Konkuk University, Seoul 05029, Republic of Korea ^e Department of Energy Engineering, Dankook University, Cheonan-si 31116, Republic of Korea

‡ These authors contributed equally to this work.



Fig. S1 The output voltage (a), and current (b) of the TENG prepared using pristine PDMS film with different curing temperature.



Fig. S2 The electricity generation process in a full cycle of the TENG under external force.

Pristine	0.01 wt.%	0.03 wt.%	0.05 wt.%	0.07 wt.%	0.1 wt.%

Fig. S3 The digital images of the composite film with different CNT concentration. (Yellow circle is indicate aggregation CNT.)



Fig. S4 XPS spectra of P-CNT and SMC.



Fig. S5 The SEM images of the SMC-PDMS with different concentration.



Fig. S6 Transfer charge of the SMC-PDMS at different SMC concentrations.



Fig. S7 The output voltage of the TENG prepared using the SMC-PDMS at interlayer distance of (a) 2 mm, (b) 4 mm.



Fig. S8 The XPS spectra of plasma-treated SMC-PDMS with different process time. (a) Full scan-spectrum, (b) C1s, (c) O1s and (d) F1s.



Fig. S9 Static contact angles of water drops on flat SMC-PDMS films in the various plasma treatment times.



Fig. S10 The output voltages of plasma treated SMC-PDMS 3 month later

Triboelectric Counter Materials Materials		Duppovation methods	Sample size —	Outputs			Dofononco
		r reparation methods		Voltage	Current density	Power	Kelerence
PDMS	Al foil	PDMS mixed SMC, plasma treatment	$2 \text{ x} 2 \text{ cm}^2$	414 V	$10.01 \ \mu A/cm^2$	7.69 W/m^2	This work
PDMS	Al foil	PDMS mixed GPs(3% mass ratio)	$2 \text{ x} 2 \text{ cm}^2$	286 V	$6.7 \ \mu A/cm^2$	3.7 W/m^2	1
PDMS	Al foil	PDMS mixed TiO _{2-x}	$3 \times 3 \text{ cm}^2$	180 V	$0.91 \ \mu A/cm^2$	1.84 W/m^2	2
PDMS	Cu	Porous PDMS, Mixed NPs(SiO ₂ ,TiO ₂ ,BaTiO ₃ ,SrTiO ₃)	$2 \text{ x} 2 \text{ cm}^2$	338 V	$9.06 \ \mu A/cm^2$	6.47 W/m^2	3
PDMS	ITO	Aligned CNT on PDMS film	$3 \times 3 \text{ cm}^2$	150 V	6 μA/cm ²	4.62 W/m^2	4
PDMS	Cellulose	Cellulose mixed with BaTiO ₃	$2 \text{ x} 2 \text{ cm}^2$	88 V	$2.1 \ \mu A/cm^2$	0.35 W/m^2	5
PDMS	PET	PDMS mixed FDTS	$2 \text{ x} 2 \text{ cm}^2$	138 V	$2.3 \ \mu\text{A/cm}^2$	0.73 W/m^2	6
PDMS	PTFE	PDMS Pyramid substrate	$3.5 \text{ x} 3.5 \text{ cm}^2$	275 V	$0.78 \ \mu A/cm^2$	0.82 W/m^2	7
PDMS	Al foil	Nanopillar-array architectured PDMS	$2 \text{ x} 2 \text{ cm}^2$	478 V	$5.85 \ \mu\text{A/cm}^2$	4.75 W/m^2	8

Table S1 Summary of TENGs performance with PDMS

Reference

- S1 X. He, H. Guo, X. Yue, J. Gao, Y. Xi and C. Hu, Nanoscale, 2015, 7, 1896-1903.
- S2 H. W. Park, N. D. Huynh, W. Kim, H. J. Hwang, H. Hong, K. H. Choi, A. Song, K. B. Chung and D. Choi, *Micromachines*, 2018, **9**, 407.
- S3 J. Chen, H. Guo, X. He, G. Liu, Y. Xi, H. Shi and C. Hu, ACS Appl. Mater. Interfaces, 2016, 8, 736-744.
- S4 H. Wang, M. Shi, K. Zhu, Z. Su, X. Cheng, Y. Song, X. Chen, Z. Liao, M. Zhang and H. Zhang, *Nanoscale*, 2016, 8, 18489-18494.
- S5 K. Shi, H. Zou, B. Sun, P. Jiang, J. He and X. Huang, *Adv. Funct. Mater.*, 2020, **30**, 1904536.
- S6 G. Z. Li, G. G. Wang, Y. W. Cai, N. Sun, F. Li, H. L. Zhou, H. X. Zhao, X. N. Zhang, J. C. Han and Y. Yang, *Nano Energy*, 2020, 75, 104918.
- S7 Z. B. Li, H. Y. Li, Y. J. Fan, L. Liu, Y. H. Chen, C. Zhang and G. Zhu, ACS Appl. Mater. Interfaces, 2019, 11, 20370-20377.
- S8 B. Dudem, N. D. Huynh, W. Kim, D. H. Kim, H. J. Hwang, D. Choi and J. S. Yu, *Nano Energy*, 2017, **42**, 269-281.